MAR 2 3 2004 E MAR 2

In re the Application of:)
) Examiner: K. Nguyen
OKU et al)
) Art Unit: 2823
Serial No.: 09/903,764)
)
Filed: July 13, 2001)
)
For:	FILM FORMING METHOD,)
	SEMICONDUCTOR DEVICE AND)
	SEMICONDUCTOR DEVICE)
	MANUFACTURING METHOD)

RESPONSE TO OFFICE ACTION OF DECEMBER 23, 2003

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Responsive to the office action of December 23, 2003, please amend the captioned application as follows: